Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L3	1	herner-scott-b.in.	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/24 10:45
L4	53	cleeves-james-m.in.	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/24 10:46
L5	6	knall-johan.in.	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/24 10:46
L6	164	(autodoping or "auto -doping") and dop$4 and undop$4	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/24 10:50
L7	828	precursor and dop$ and (cvd or "chemical vapor deposition") and (cmp or "chemical mechanical polishing")	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/24 10:55
L8	70	precursor same dop$ same undop$4 same (cvd or "chemical vapor deposition")	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/24 10:54
L9	2027	dop$ same undop$4 same (cvd or "chemical vapor deposition")	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/24 10:54
L10	133	dop$ same undop$4 same (cvd or "chemical vapor deposition") same (cap or capping)	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/24 10:55
L11	61	precursor and dop$ and (cvd or "chemical vapor deposition") and (cmp or "chemical mechanical polishing") and dummy	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/24 11:07
L12	1	"6432845".PN.	USPAT; USOCR	OR	OFF	2005/02/24 11:00
L14	79	7 and "memory array"	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/24 11:15